LASER INTERFEROMETER GRAVITATIONAL WAVE OBSERVATORY

LIGO

SPECIFICATION

E2100222-v10

DrawingNo Vers

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Specification: Silicon Test Mass HR/AR Coatings, 40m Mariner phase I

APPROVALS	DATE	REV	DCN NO.	CHECK
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1 Description

A list of the high reflectivity (HR) and anti-reflective (AR) coatings for 40m Mariner Phase I Silicon test masses.

2 General Specifications

Wavelengths: 2128.2 nm and 1418.8 nm

Polarization: S

Coating Scatter: < 5 ppm

Type: low absorption, ion beam sputtered deposition

Diameter: 7 cm around optic center

3 HR Coatings

Coating A: (HR: ETMX / ETMY) [requirements stated in decreasing order of importance]

Requirement 1: (absolute value)

- 2128.2 nm / AOI: 0 degrees
 - $T_{ETMX} = 10 \pm 5 \text{ ppm}$
 - $T_{\text{ETMY}} = 10 \pm 5 \text{ ppm}$

Requirement 2: (differential value)

- 2128.2 nm / AOI: 0 degrees
 - $|T_{ETMX} T_{ETMY}| < \pm 100 \text{ ppm, best effort} < \pm 10 \text{ ppm}$

Requirement 3: (absolute value)

- 1418.8 nm / AOI: 0 degrees
 - $T_{ETMX} = 50 \pm 50$ ppm, best effort ± 20 ppm
 - $T_{ETMY} = 50 \pm 50$ ppm, best effort ± 20 ppm

Requirement 4: (differential value)

- 1418.8 nm / AOI: 0 degrees
 - $|T_{\text{ETMX}} T_{\text{ETMY}}| < \pm 100 \text{ ppm, best effort} < \pm 10 \text{ ppm}$

Coating B: (HR: ITMX / ITMY) [requirements stated in decreasing order of importance]

Requirement 1: (differential value)

- 2128.2 nm / AOI: 0 degrees
 - $|T_{ITMX} T_{ITMY}| < \pm 100 \text{ ppm, best effort} < \pm 10 \text{ ppm}$

Requirement 2: (absolute value)

- 2128.2 nm / AOI: 0 degrees
 - $T_{ITMX} = 2000 \pm 200 \text{ ppm}$
 - $\bullet \quad T_{ITMY} = 2000 \pm 200 \text{ ppm}$

Requirement 3: (absolute value)

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- 1418.8 nm
 - $T_{ITMX} = 50 \pm 50$ ppm, best effort ± 20 ppm
 - $T_{ITMY} = 50 \pm 50$ ppm, best effort ± 20 ppm

Requirement 4: (differential value)

- 1418.8 nm / AOI: 0 degrees
 - $|T_{ETMX} T_{ETMY}| < \pm 100 \text{ ppm, best effort} < \pm 10 \text{ ppm}$

4 AR Coatings

Coating C: (AR: ETMX / ETMY) [requirements stated in decreasing order of importance]

Requirement 1: (absolute value)

- 2128.2 nm / AOI: 0.5 degrees
 - $R_{ETMX} < 2000 \text{ ppm}$
 - $R_{ETMY} < 2000 \text{ ppm}$

Requirement 2: (absolute value)

- 1418.8 nm / AOI: 0.5 degrees
 - $R_{ETMX} < 1000 \text{ ppm}$
 - $R_{ETMY} < 1000 \text{ ppm}$

Coating D: (AR: ITMX / ITMY) [requirements stated in decreasing order of importance]

Requirement 1: (absolute value)

- 2128.2 nm / AOI: 0.5 degrees
 - $R_{ITMX} < 1000 \text{ ppm}$
 - $R_{ITMY} < 1000 \text{ ppm}$

Requirement 2: (absolute value)

- 1418.8 nm / AOI: 0.5 degrees
 - $R_{ITMX} < 1000 \text{ ppm}$
 - $R_{ITMY} < 1000 \text{ ppm}$

5 Metrology

Coating vendor to provide:

- 1. Two 1" witness samples from each coating run
- 2. Spectrophotometer graphs of the reflectance and transmittance of the HR
- 3. Spectrophotometer graphs of the reflectance of the AR coating

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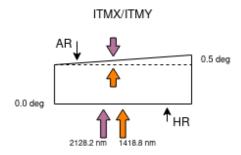
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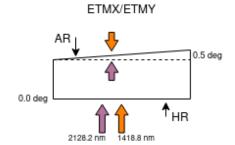
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6 Drawings

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7 Supplementary information

Attached are example stacks with 46 layers demonstrating similar to the required performance. The documents are:

- 1. <u>ETM_Layers.pdf</u> showing the ETM HR coating normalized E-field amplitude from the incident surface in the top, and the stack layer thicknesses in the bottom.
- 2. <u>ETM_R.pdf</u> showing the ETM HR spectral R and transmission T for the example stack.
- 3. <u>ITM_Layers.pdf</u> showing the ITM HR coating normalized E-field amplitude from the incident surface in the top, and the stack layer thicknesses in the bottom.
- 4. <u>ITM_R.pdf</u> showing the ITM HR spectral R and transmission T for the example stack.
- 5. <u>test_mass_HR_stacks-2.xlsx</u> which contains the raw data for the aforementioned example stacks.